Docket No. 278536US26PCT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Kazuyoshi YAMAZAKI, et al.

SERIAL NO: 10/549,285 GAU: 1792

FILED: September 16, 2005 EXAMINER: Keath T. Chen

FOR: SUBSTRATE TREATING APPARATUS AND METHOD OF SUBSTRATE

**TREATMENT** 

## REQUEST FOR EXTENSION OF TIME UNDER 37 C.F.R. 1.136

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

C	IR	٠
J	11/	٠

It is hereby requested that a three month extension of time be granted to March 30, 2010 for				
filing a response to the Official Action dated:				
responding to the requirements in the Notice of Allowability dated:				
filing the	e Formal Drawings. The Issue Fee due	has been timely filed.		
respondi	responding to the Notice to File Missing Parts of Application dated:			
filing a Request for Continued Examination (RCE). A response to the final rejection is being filed herewith.				
filing an Appeal Brief. A Notice of Appeal was filed on:				
Applica	Applicant claims small entity status. See 37 CFR 1.27.			
filed), or is	ed fee of \$1,110.00 is being made by credit of attached hereto (if paper filed), and any furt of Record's Deposit Account No. 15-0030.	card payment online (if electronically her charges may be made against the		
		. 6 11 . 6 . 1 . 14 1		

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, L.L.P.

Steven P. Weihrouch

Registration No. 32,829

Customer Number

22850

Tel. (703) 413-3000 Fax. (703) 413-2220 (OSMMN 07/09) Ronald A. Rudder, Ph.D.

Registration No. 45,618

Edwin D. Garlepp Registration No. 45,330